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CEPC Beam energy calibration

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On behalf of the CEPC Energy Calibration Group




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Working group and collaborations

- **IHEP:** Xinchou Lou, Yongsheng Huang, Guangyi Tang, Manqi Ruan, Jianyong Zhang, Guangpeng An, Yiwei Wang, Zhe Duan, Guanglei Xu(timing control), Gang Wu(spatial alignment), Hongbo Zhu (Si detector), Shanhong Chen, Meiyu Si
- **CIAE:** Naiyan Wang(Compton scattering system design), Baozhen Zhao(laser system), Xiaofeng Xi (time synchronization)
- **China West Normal University:** Xiaofei Lan, (simulation of the Cherenkov radiation, the simulation of new fiber detector)
- **University of Science and Technology of China:** Shubin Liu, Changqing Feng(electronic system and test)
- **CERN factory & CIVIDEC:** CEO, CVD diamond detector and test
- **Wuhan University:** Yuan Chen(Magnetic design)

Outline

-  **Configuration of CEPC/FCC**
-  **Laser-Compton scattering method**
-  **Microwave-Compton scattering method**

Configuration of beam-energy calibration system @ CEPC

Laser-Compton Scattering method

Microwave-Compton scattering method

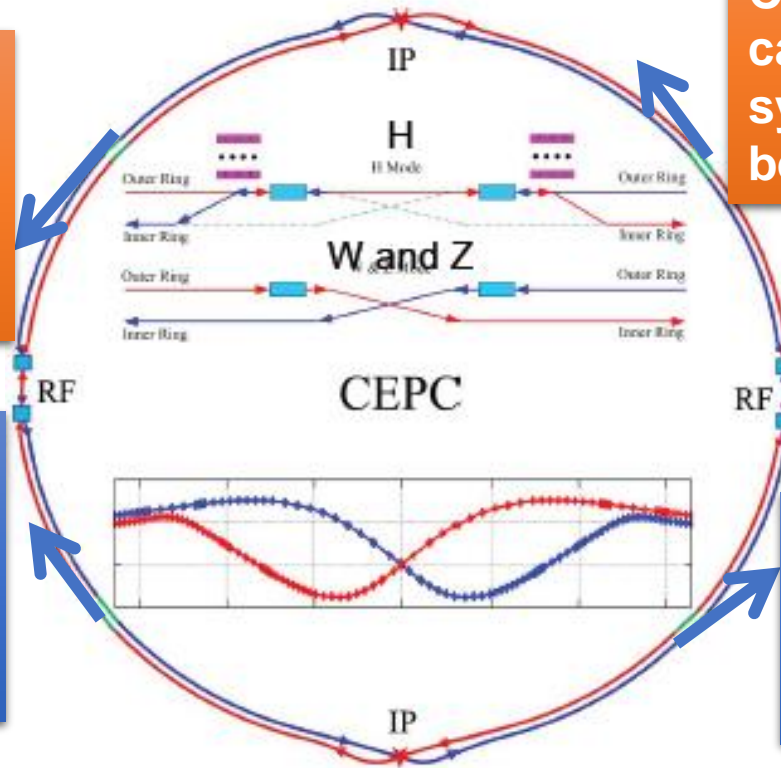
γ SR beamline and applications

Microwave-Compton beam calibration system+ γ SR beamline

Laser-Compton beam calibration system & beam dump line

Microwave-Compton beam calibration system+ γ SR beamline

Laser-Compton beam calibration system & beam dump line



CEPC collider ring (100km)

Outline

1

Configuration of CEPC/FCC

2

Laser-Compton scattering method

- Motivation and requirement
- Configuration
- Principle
- Simulation & Results

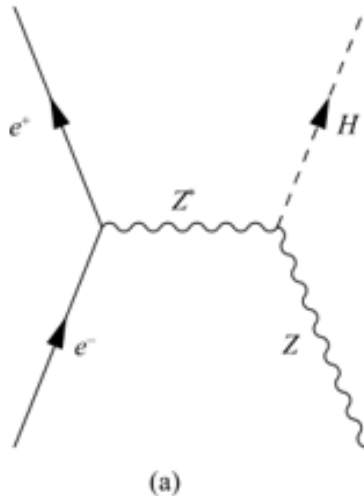
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Microwave-Compton scattering method

Motivation & Requirements for beam energy

➤ Motivation

- The mass & the width of Z/W boson can be measured at CEPC **Z pole and W threshold scans runs**.
- **The dominant systematic** is expected to come from beam energy measurements.



Recoil mass method

$$e^+e^- \rightarrow ZH$$

$$m_H^2 = (\sqrt{s} - E_{l\bar{l}})^2 - p_{l\bar{l}}^2$$

- The measurement of the ZH production cross section and the **Higgs boson** using the recoil mass method.
- The beam energy is an **input parameter** to perform measurements of the Higgs properties

➤ Requirements

- The CEPC physics program requires precise determination of beam energies with an accuracy of the order of **1 MeV@ Higgs** and **100 keV@Z/W**.

Resonant depolarization method

➤ Resonant depolarization(RD) method @VEPP-4M LEP

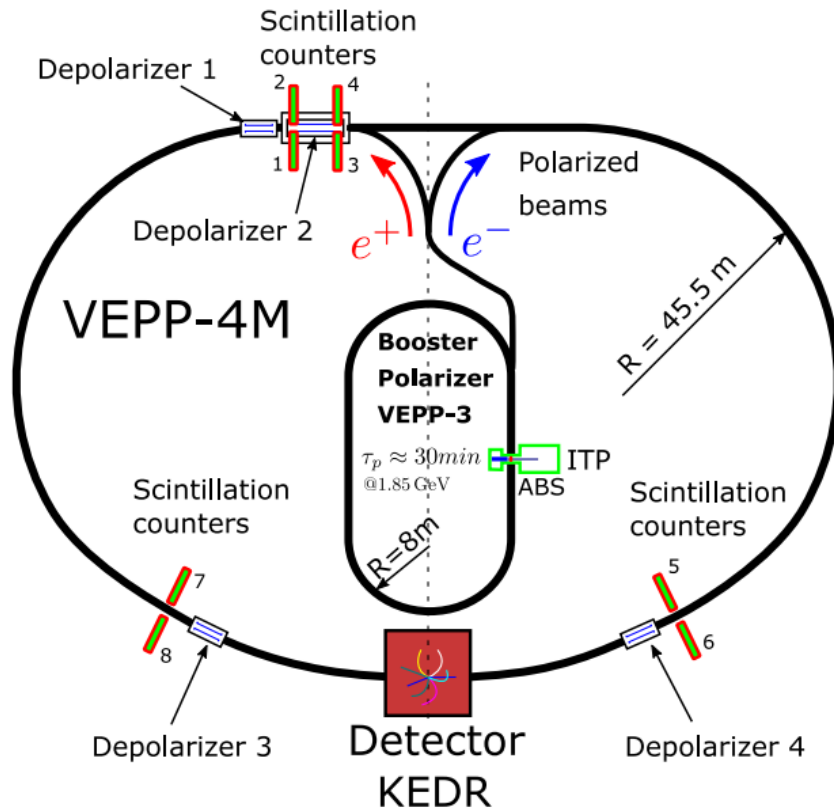


Table: Experiment of calibrated beam energy by RD

粒子	实验	时间
Φ, K^\pm	VEPP-2M ^[78, 79]	1975-1979
$J/\psi, \psi(2S)$	VEPP-4 ^[80, 81]	1980-1981
$\Upsilon(1S), \Upsilon(2S), \Upsilon(3S)$	VEPP-4 ^[82--86]	1982-1986
K^0, ω	VEPP-2M CMD ^[93]	1987
Z	LEP ^[87]	1993
$J/\psi, \psi(2S), \tau, D^0$	VEPP-4M ^[89--92]	2003-2015

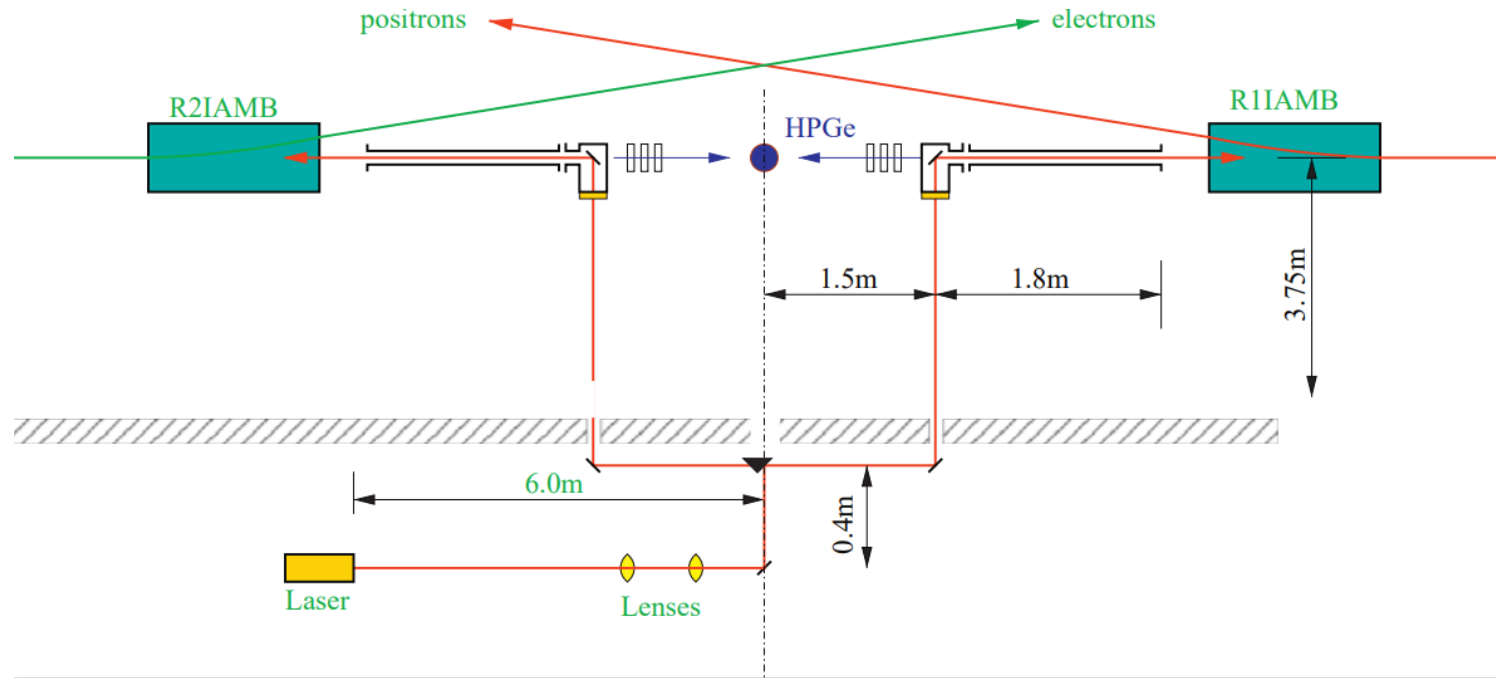
- Scheme of VEPP-4M complex from the view of polarization experiments.

- The resolution is achieved in VEPP-4M is $1e-6$.
- CEPC, achieving the required beam polarization of at least 5% to 10% for RD in the Higgs mode may be challenging.

The beam energy measurement system for the Beijing electron-positron collider

➤ Compton Back Scattering method(CBS) @VEPP-4M BEPCII VEPP-2000

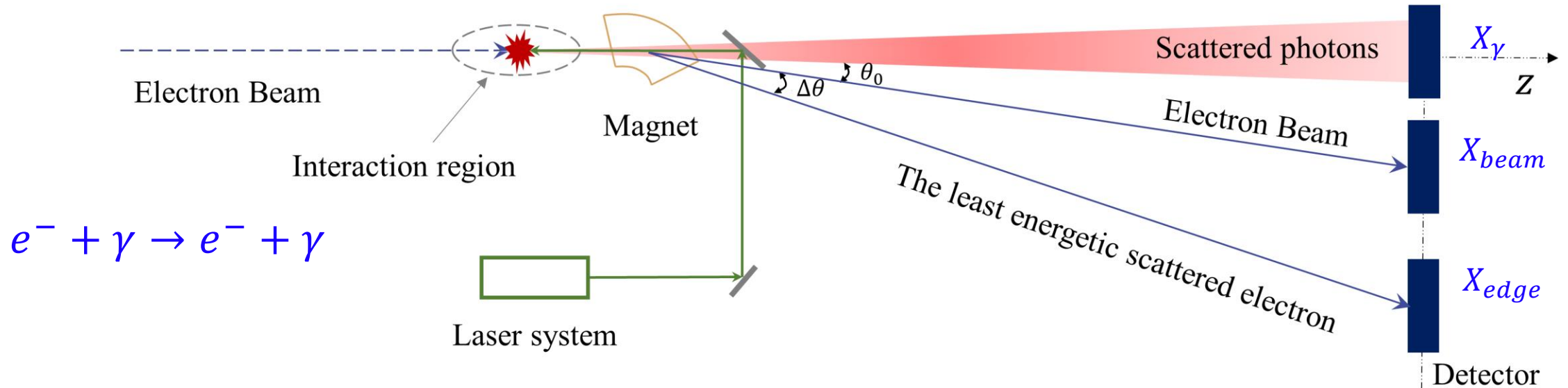
$$E_{beam} = \frac{E_{\gamma}}{2} \left[1 + \sqrt{1 + \frac{m_e^2}{\epsilon_{\gamma} E_{\lambda}}} \right]$$



- Measuring the energy of the scattered photons (E_{γ}) by HPGe detector.
- The relative systematic uncertainty of the electron and positron beam energy determination is estimated as 2×10^{-5} .

CEPC beam energy calibration

- **Method:** the electron beam distribution after Compton back-scattering combining a bending magnet



Electron beam based on CDR		Nd:YAG Laser system	
Energy (GeV)	120	λ (nm)	532
N_e	15×10^{10}	Energy(J)	0.1
Collision angle α		~ 2.35 mrad	
Compton scattering cross section		202 mb	

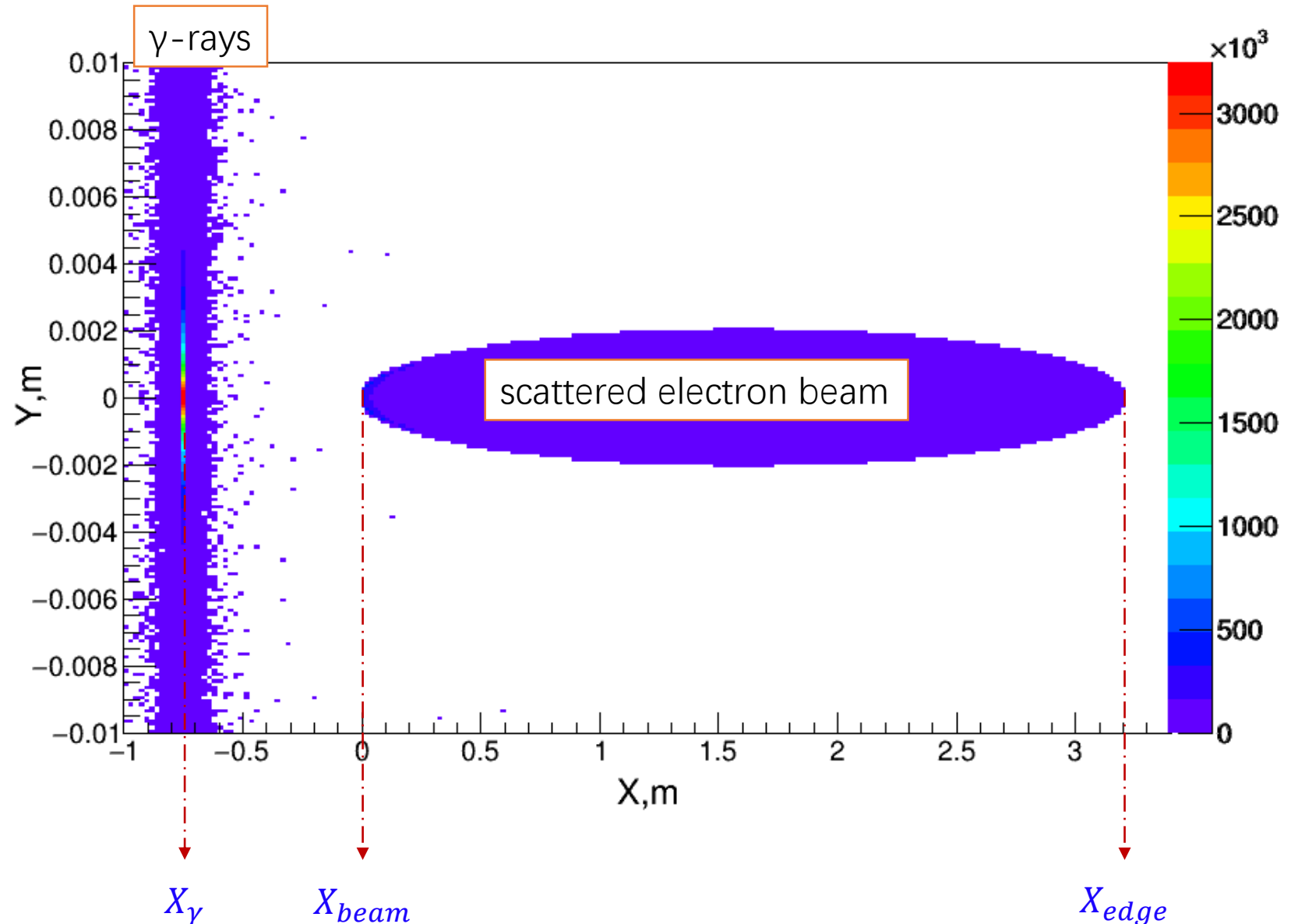
$$E_{beam} = \frac{(m_e c^2)^2}{4w_0} \frac{X_{edge} - X_{beam}}{X_{beam} - X_\gamma}$$

- The technique is “non-destructive”:
 - ~1/10000 Compton scattered particles in one collision.

Spatial distribution of scattered particles

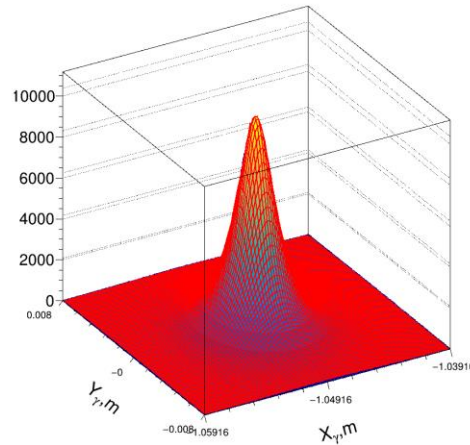
- Beam energy can be calibrated by:
 - Position of the main electron beam particles(X_{beam}).
 - Position of scattered photons(X_{γ}).
 - Position of the scattered electrons with the least energy(X_{edge}).

$$E_{beam} = \frac{(m_e c^2)^2}{4W_0} \frac{X_{edge} - X_{beam}}{X_{beam} - X_{\gamma}}$$

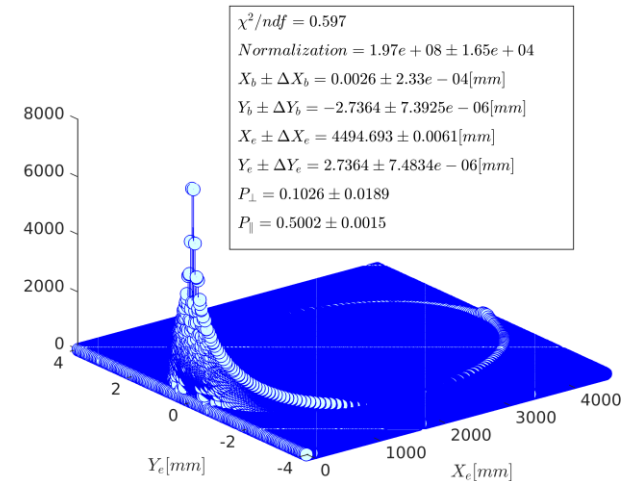


Statistical error

- Tens of seconds of data taking is necessary to achieve accuracy < 1 MeV@Higgs mode.



Fit result	
Mean x	-1.0491571 m
Mean y	1.5885e-05 m
Chi2/Ndf	151930/79995
position deviation x	-2.31105e-07 +/- 3.14889e-07 m
position deviation y	5.46969e-07 +/- 7.02995e-07 m
Longitudinal polarization	0.5003 +/- 0.00033
Transverse polarization	0.0993 +/- 0.00247



IP-Detector distance	100 m	200 m	300 m
Pixel size	$100\mu\text{m} \times 50\mu\text{m}$	$500\mu\text{m} \times 100\mu\text{m}$	$2\text{mm} \times 200\mu\text{m}$
$X_Y + \Delta X_Y [mm]$	$-299.762 \pm 8.905 \times 10^{-5}$	$-674.460 \pm 4.475 \times 10^{-5}$	$-1049.16 \pm 1.134 \times 10^{-4}$
$X_{\text{beam}} + \Delta X_{\text{beam}} [mm]$	$-0.0011 \pm 1.8492 \times 10^{-4}$	$-0.0009 \pm 7.3215 \times 10^{-4}$	-0.0015 ± 0.0018
$X_{\text{edge}} + \Delta X_{\text{edge}} [mm]$	1284.1928 ± 0.0037	2889.4319 ± 0.0132	4494.6437 ± 0.0314
$E_b [GeV]$	119.9999	120.0003	119.9991
$\Delta E_b [MeV]$	0.356	0.573	0.875

Systematic deviation

$$E_{beam} = \frac{(m_e c^2)^2 \Delta\theta}{4w_0 \theta_0} = \frac{(m_e c^2)^2 X_{edge} - X_{beam}}{4w_0 X_{beam} - X_\gamma} + \mathcal{O}$$

$\Delta\theta$ is the angle between the main beam and the scattered beam of min. energy

θ_0 is the bending angle of BM

\mathcal{O} denotes the systematic deviations

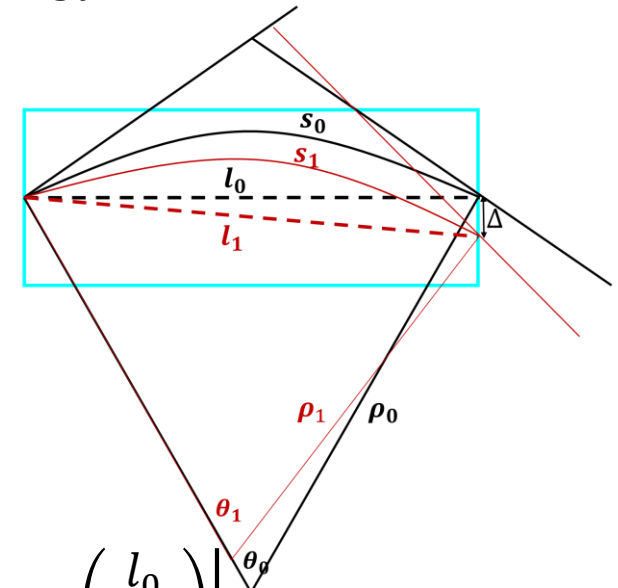
(1) $\frac{\Delta\theta}{\theta_0}$ and $\frac{\tan\Delta\theta}{\tan\theta_0}$

(2) Differences in trajectory for different energies

- $\Delta E = 9.75 \pm 0.04$ MeV for a magnet with a magnetic field strength of 0.5 T (deviation is 0.2%) and length is 3 m.

$$\Delta s = |s_1 - s_0| = \left| 2\rho_1 \arcsin\left(\frac{l_1}{2\rho_1}\right) - 2\rho_0 \arcsin\left(\frac{l_0}{2\rho_0}\right) \right|$$

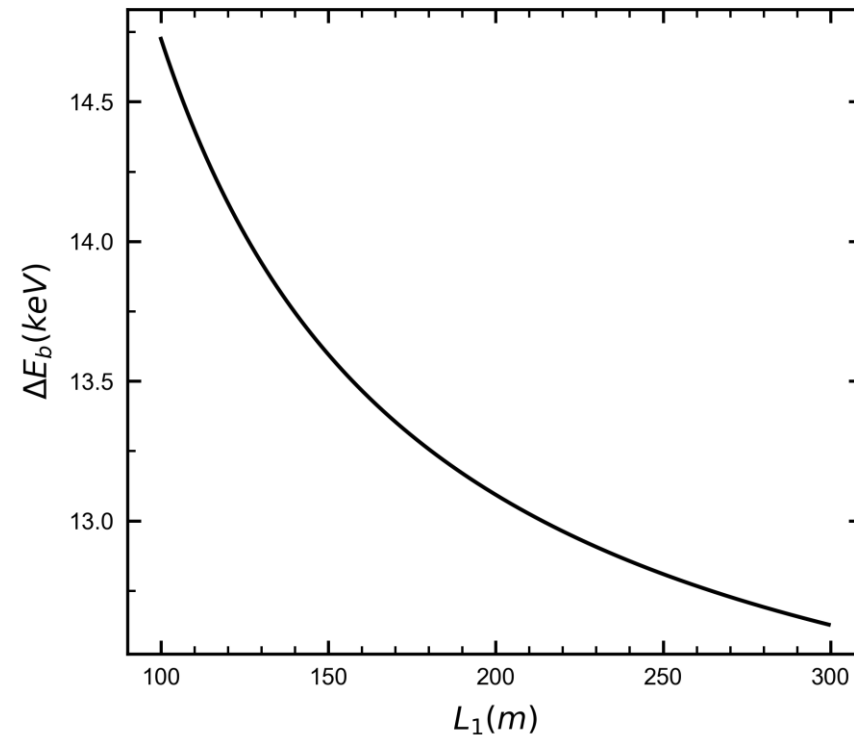
- Particles of different energies have different trajectories in the BM $\rightarrow \Delta E = 5.76$ MeV



Systematic uncertainty

- Considering the measurement of magnet strength and drift distance.
- The relative error is assumed to be $\Delta B/B \approx 10^{-4}$ and $\Delta L/L \approx 10^{-4}$
- The systematic uncertainties is about 20 keV

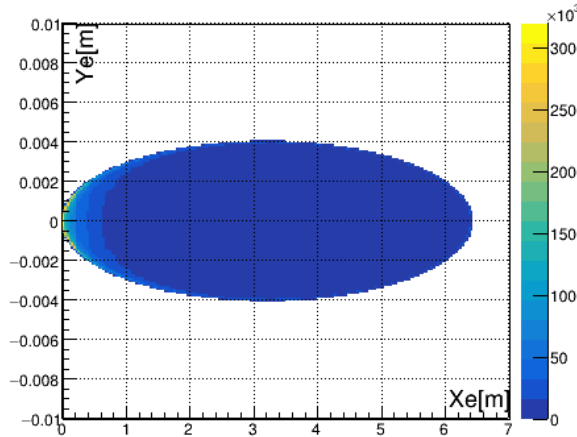
$$\Delta E = \sqrt{\Delta E_B^2 + \Delta E_L^2}$$



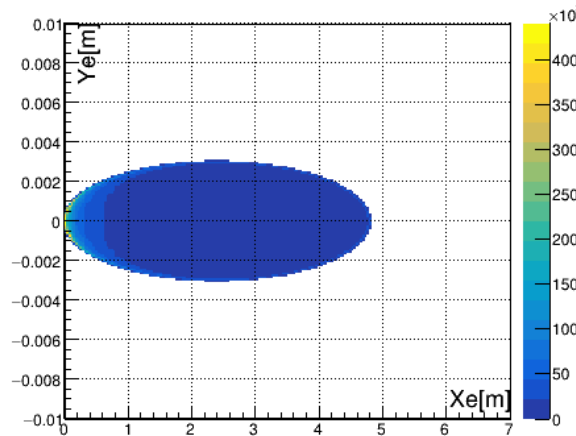
- More systematic error sources need to be considered.
- Extrapolating the center-of-mass energy needs to be discussed later.

The choice of the laser parameters

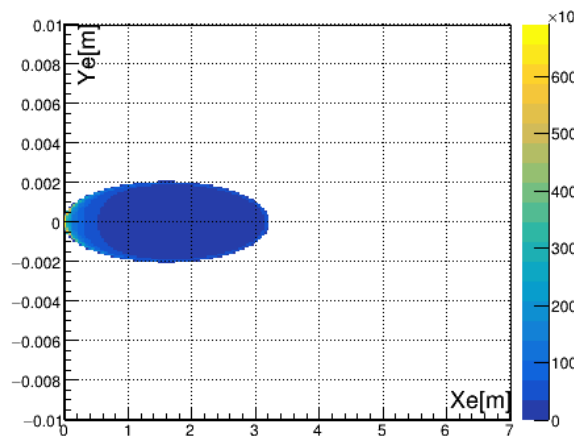
- The distribution of scattered electrons



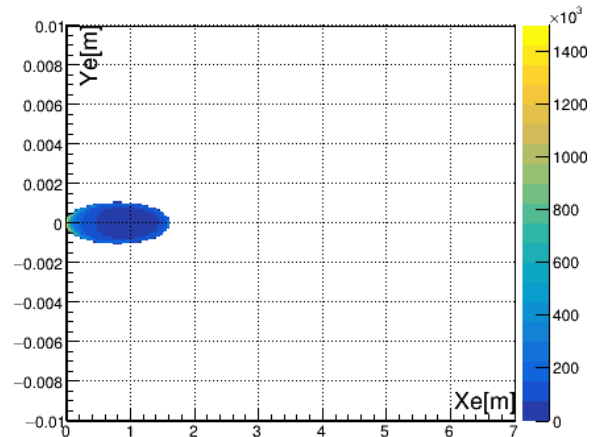
$\lambda = 256 \text{ nm}$



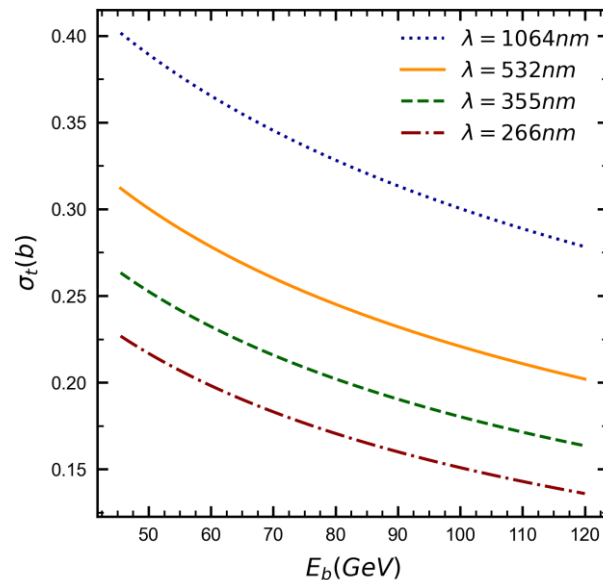
$\lambda = 355 \text{ nm}$



$\lambda = 532 \text{ nm}$



$\lambda = 1064 \text{ nm}$



- (1) Restrictions on the photon energy:

$$\frac{\delta E_{beam}}{E_{beam}} = \frac{\delta \omega_0}{\omega_0} = 8.3 \times 10^{-6}$$

- (2) Restrictions on the photon wavelength:

- To reduce drift distance :

- Short wavelength laser(532 nm \rightarrow 266 nm)
- Dipole length shorten (combining the system layout)

Comparison of the key parameters for different models in CEPC

Guangyi Tang

	Higgs mode	Z mode	WW scan	$t\bar{t}$ scan
$E_{\text{beam}}/\text{GeV}$	120	45	80	175
X_{edge}/m	6.16352	9.29686	7.10343	5.52276
X_{beam}/m	1.87935	5.00178	2.81903	1.28868
$\delta X_{\text{edge}}/\text{m}$		2.6×10^{-5}		
$\delta X_{\text{beam}}/\text{m}$		6×10^{-8}		
$\delta E_{\text{beam}}/\text{MeV}$	1.0	0.3	0.6	1.8

- The statistical uncertainties of beam energy are not included here

• <https://aip.scitation.org/doi/10.1063/1.5132975>

Beam energy → the center-of-mass energy

$$\langle \sqrt{s} \rangle = 2\sqrt{E_+ E_-} \cos \frac{\alpha}{2}$$

➤ Some discussion

- More systematic error sources need to be considered.
- Extrapolating the center-of-mass energy needs to be considered.
- Potential corrections of c.m. energy
 - The correlated effects of dispersion
 - Collision offsets
 - Difference between the electron and positron beams
- Beam energy uncertainties from surroundings
 - Tidal effect → collider orbit circumference
 - Railway → magnetic field

Outline

1

Configuration of CEPC/FCC

2

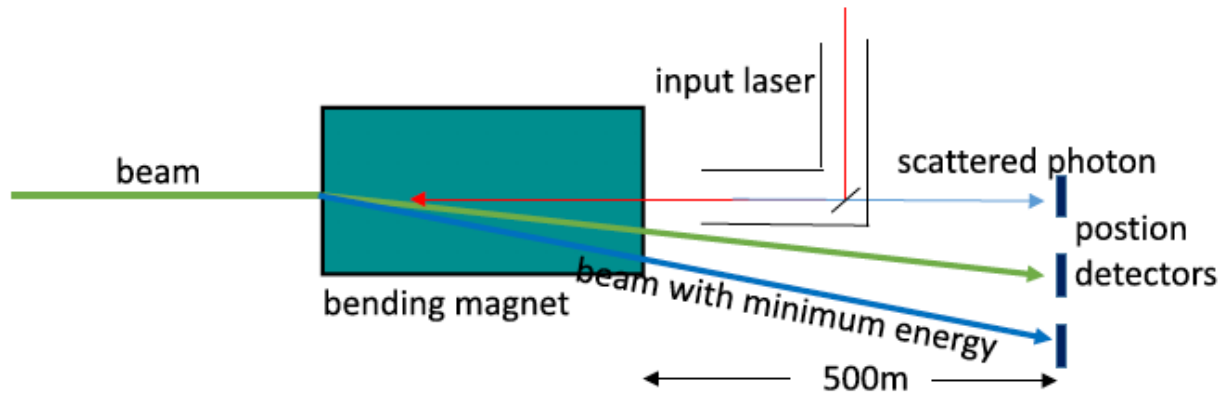
Laser-Compton scattering method

3

Microwave-Compton scattering method

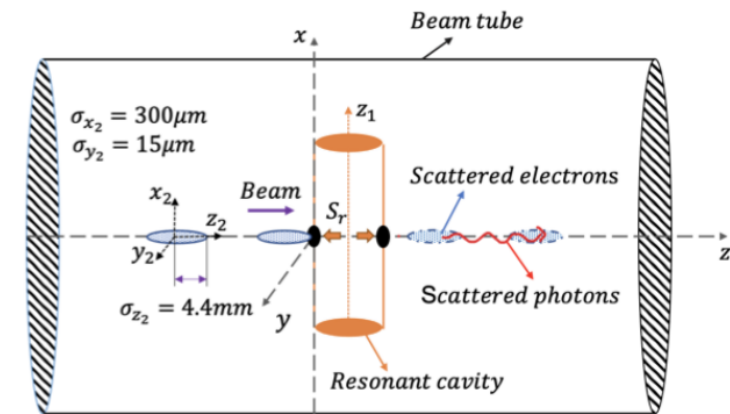
Microwave-Compton scattering method

Laser Compton backscattering^[1]



- Independent extraction device.
- Separately detect the positions of scattered electrons, scattered photons and unscattered beams.
- **With some proper corrections, the beam energy uncertainty of the Higgs mode is around 2 MeV.**

Microwave-beam Compton backscattering^[2]



- Use synchrotron radiation lead wire.
- Detection of the maximum energy of scattered photons by a HPGe detector.
- **If the beam energy is calibrated within 10MeV, it will be interesting and worth doing.**

[1] *Review of Scientific Instruments* 91, 033109 (2020).

[2] *Nuclear Inst. and Methods in Physics Research, A* 1026 (2022) 166216,

Microwave-Compton method of calibration of beam energy

Head-to-head collision $\alpha = \pi$:

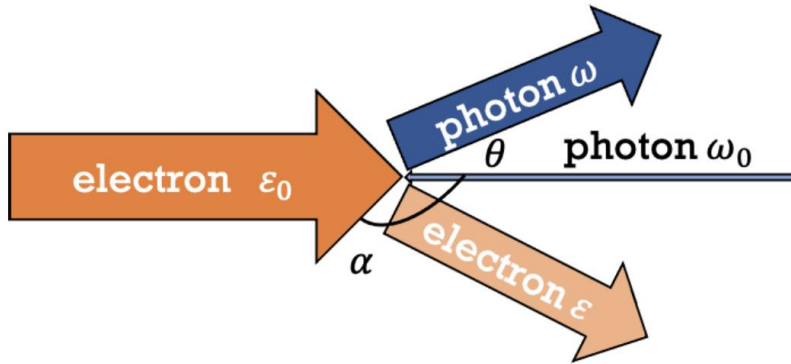


Figure 1. Compton backscattering process

Considering $\epsilon_0 \gg m \gg \omega_0$

$$\omega_{max} = \frac{\epsilon_0^2 \sin^2(\frac{\alpha}{2}) + \frac{m^2}{4} \cos \alpha}{\epsilon_0 \sin^2(\frac{\alpha}{2}) + \frac{m^2}{4\omega_0}}$$

$$\epsilon_0 = \frac{\omega_{max}}{2} \left(1 + \sqrt{1 + \frac{m^2}{\omega_0 \omega_{max} \sin^2(\frac{\alpha}{2})}} \right)$$

Scattered photons:

$$\frac{dN_\gamma}{dt} = L\sigma \quad \longrightarrow \quad \frac{dN_\gamma}{d\omega dt} = L \frac{d\sigma}{d\omega}$$

Table I. CEPC parameters in Higgs mode.

	Higgs
Beam energy ϵ_0 (GeV)	120
Bunch number B	242
Particles/bunch $N_2(10^{10})$	15
Bunch spacing (ns)	680
Beam current I (mA)	17.4
Bending radius ρ (km)	10.7
Beam size σ_{x2}/σ_{y2} (μm)	200-450/5-20
Bunch length σ_{z2} (mm)	4.4

- The HPGe detector has a good calibration of gamma energy within **1 to 10 MeV**.
- The energy of the scattered photons is chosen to be in the range of **(8–20 MeV)** compared with the synchrotron radiation background.

Choosing $\omega_{max} = 9\text{MeV}$

$$\omega_0 = 4.08 \times 10^{-5} \text{eV} \quad \lambda = 3.04 \text{ cm}$$

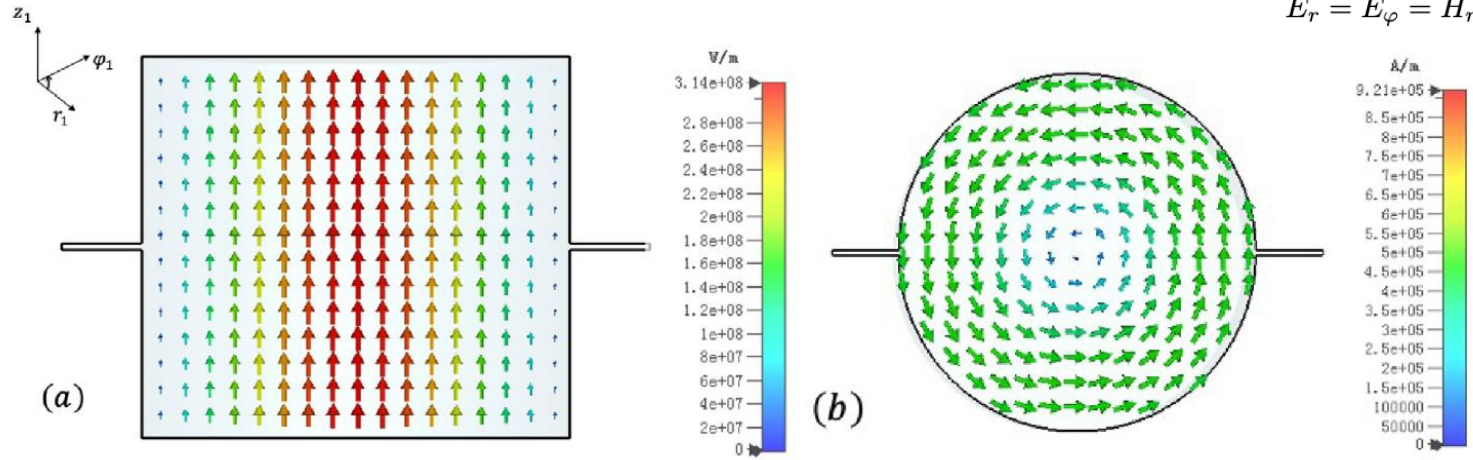
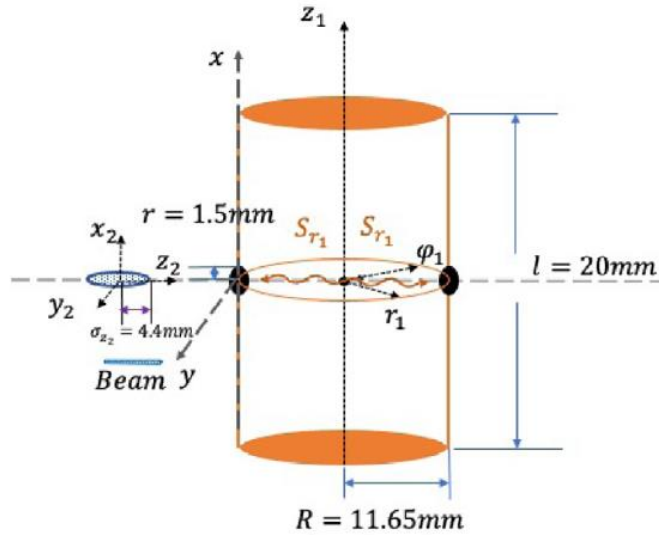
Resonant Cavity

➤ Choosing the **TM₀₁₀ mode** of the standing wave cavity: $\lambda = \frac{2\pi}{K} = 2.613R$

$$E_{z1} = E_m J_0(K_c r) e^{j\omega t}$$

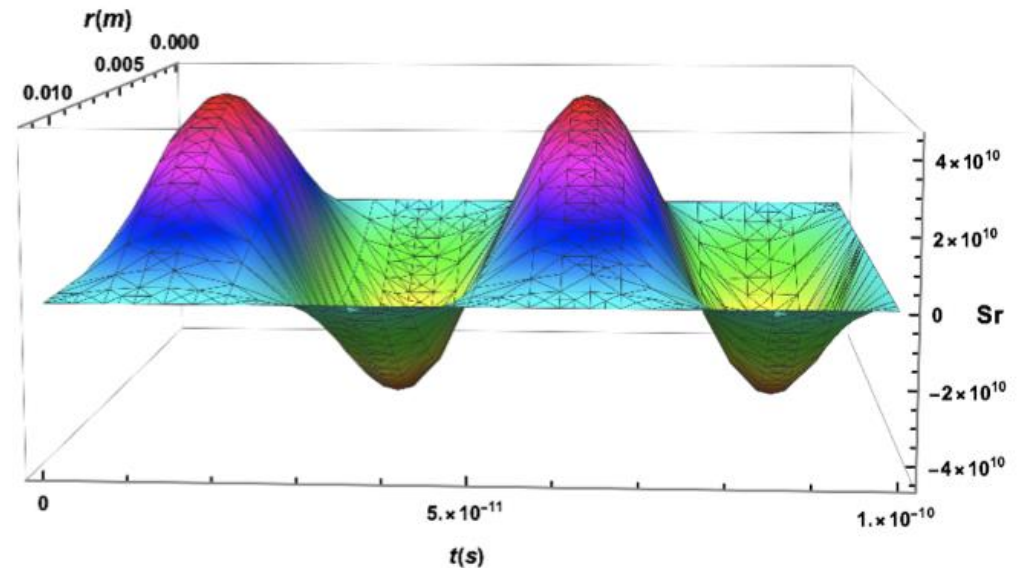
$$H_\varphi = j E_m \frac{1}{\eta} J_1(K_c r) e^{j\omega t}$$

$$E_r = E_\varphi = H_r = H_z = 0$$

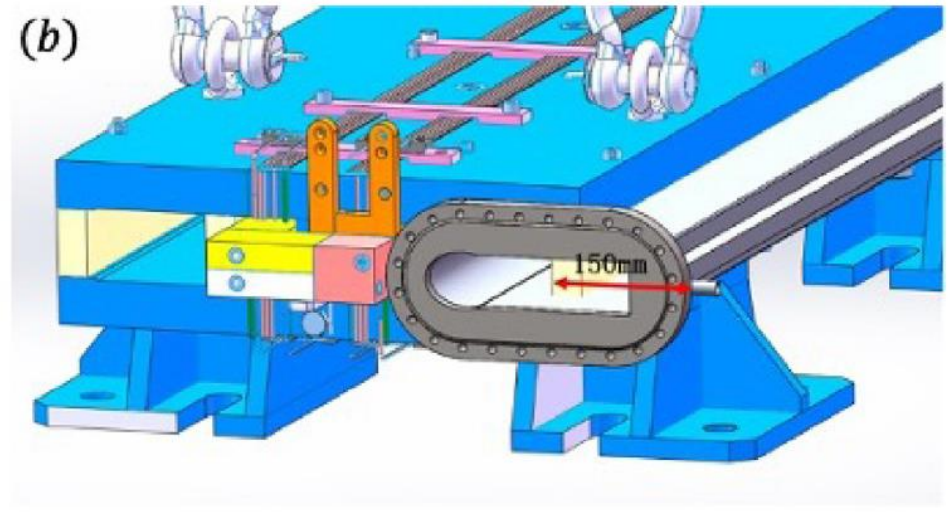
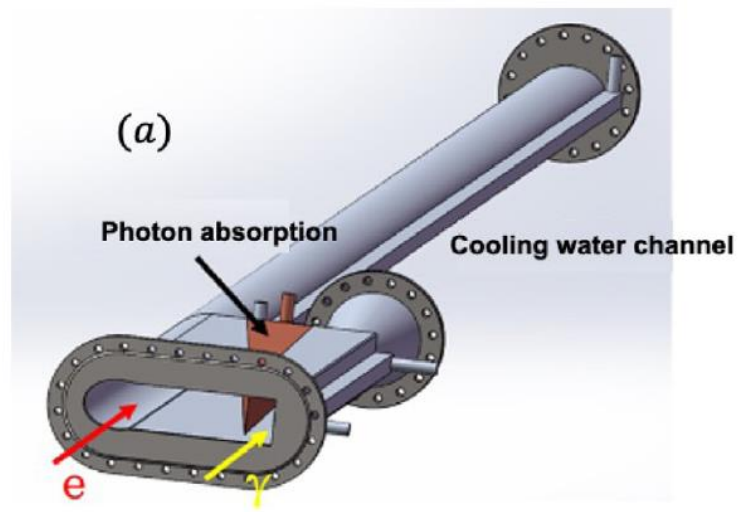
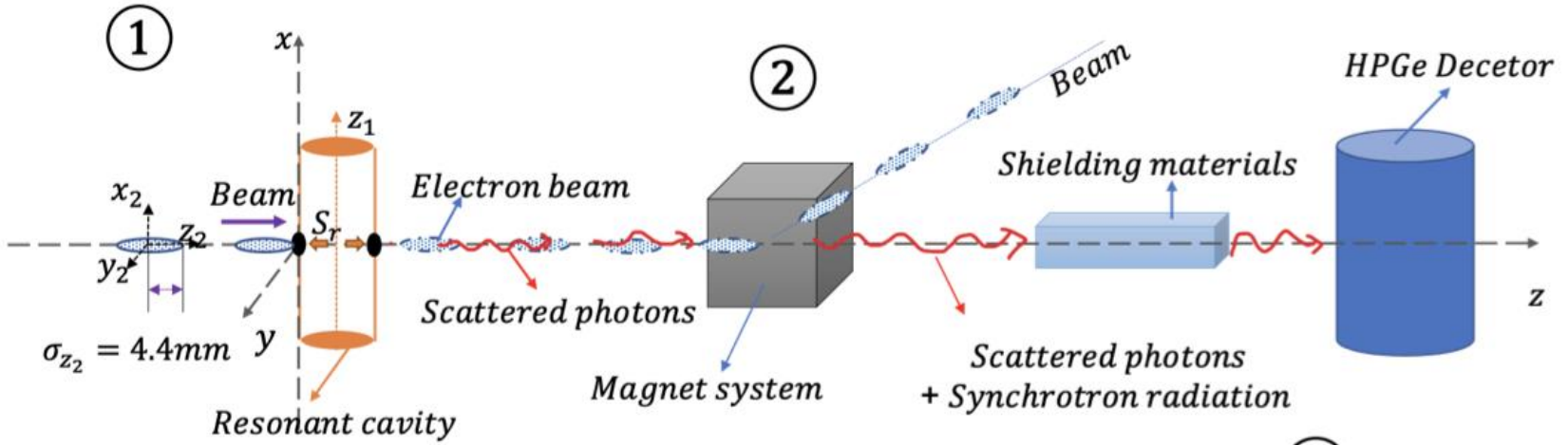


➤ The Poynting vector:

$$S_r = -E_z \times H_\varphi = \frac{E_m^2 J_0(K_c r) J_1(K_c r) \sin(\omega t) \cos(\omega t)}{\eta}$$



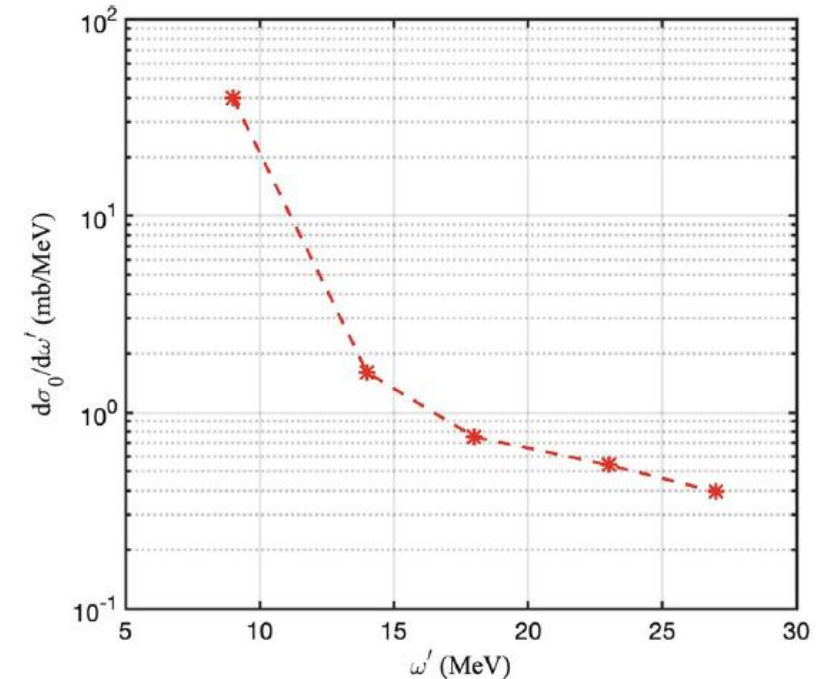
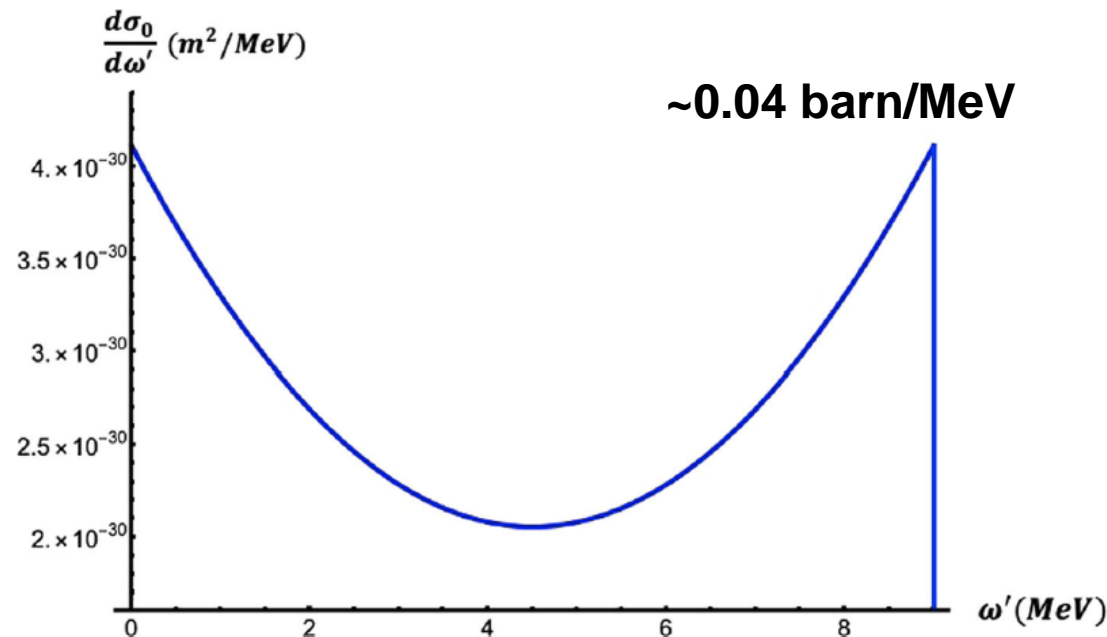
System Design



- The electrons and photons separation device designed for the beam line of the synchrotron radiation applications on CEPC.

Differential cross-section

$$\frac{d\sigma_0}{d\omega'} = \left| \mathbf{F}_{(TM_{010})}^{(1)} \right|^2 \cdot 2\pi \frac{r_e^2}{\kappa^2(1+u)^3} \frac{\varepsilon_0}{(\varepsilon_0 - \omega')^2} \left\{ \kappa \left[1 + (1+u)^2 \right] - 4 \frac{u}{\kappa} (1+u)(\kappa - u) \right\}. \quad (F_{(TM_{010})}^{(1)} = \mathbf{0.608484})$$



- For the microwaves with a wavelength of 3.04 cm collide head-on with 120 GeV electrons on CEPC, the maximum energy of scattered photons is $\omega' = 9$ MeV.

- The maximum energy of the nonlinear Compton scattering is $\omega' = 14$ MeV, $\omega' = 18$ MeV, $\omega' = 23$ MeV, $\omega' = 27$ MeV, corresponding to the nonlinear order 2, 3, 4, 5, respectively.

Luminosity and Number of Scattered Photons

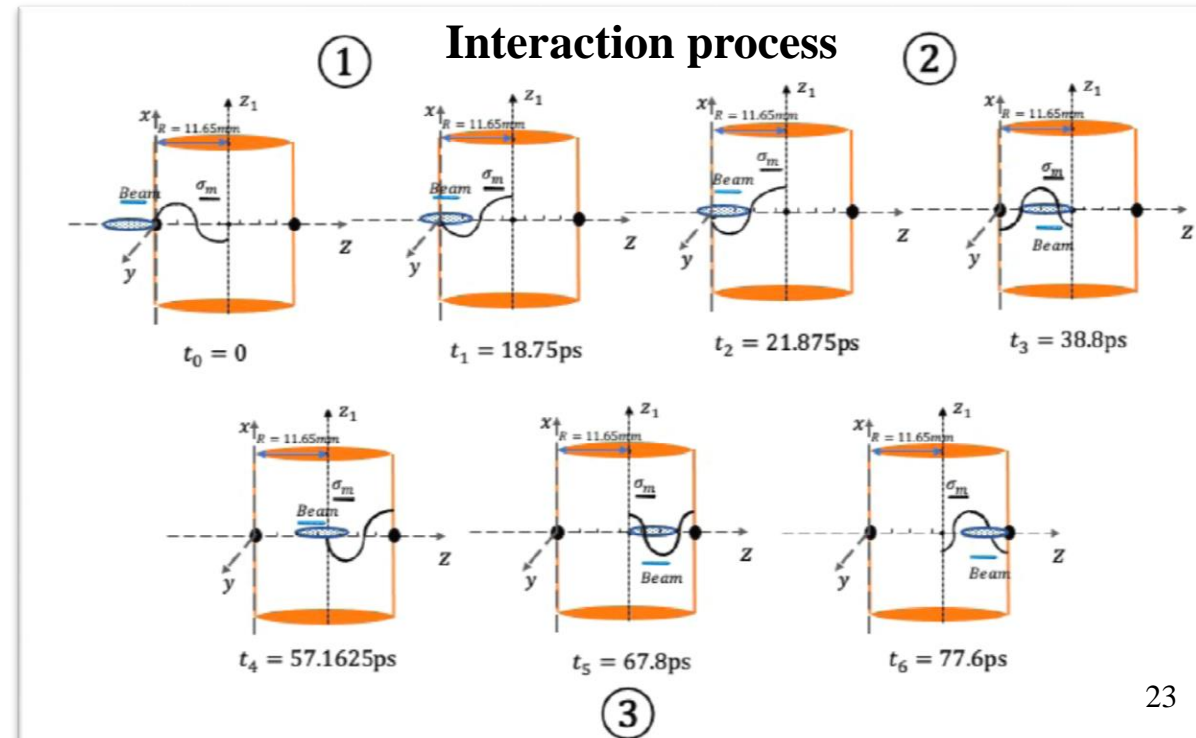
- The areal density of the photon number ($1/(m^2 \cdot s)$):

$$\vec{\sigma}_m = \frac{\vec{S}}{\omega_0} = \frac{1}{\eta\omega_0} E_m^2 J_0(K_c r_1) J_1(K_c r_1) \sin(\omega t) \cos(\omega t) \vec{r}_1$$

- The luminosity in the Compton scattering process : $B = 1, f' = 1$

$$L = N_2 \cdot 2Bf' \int \sigma_m(r_1) f_2(x_2, y_2, z_2, t) dx dy dz dt \quad f_2(x_2, y_2, z_2, t) = \frac{1}{2\pi\sigma_{x2}\sigma_{y2} \cdot \sqrt{2\pi}\sigma_{z2}} \exp\left[-\frac{1}{2}\left(\frac{x_2^2}{\sigma_{x2}^2} + \frac{y_2^2}{\sigma_{y2}^2} + \frac{z_2^2}{\sigma_{z2}^2}\right)\right]$$

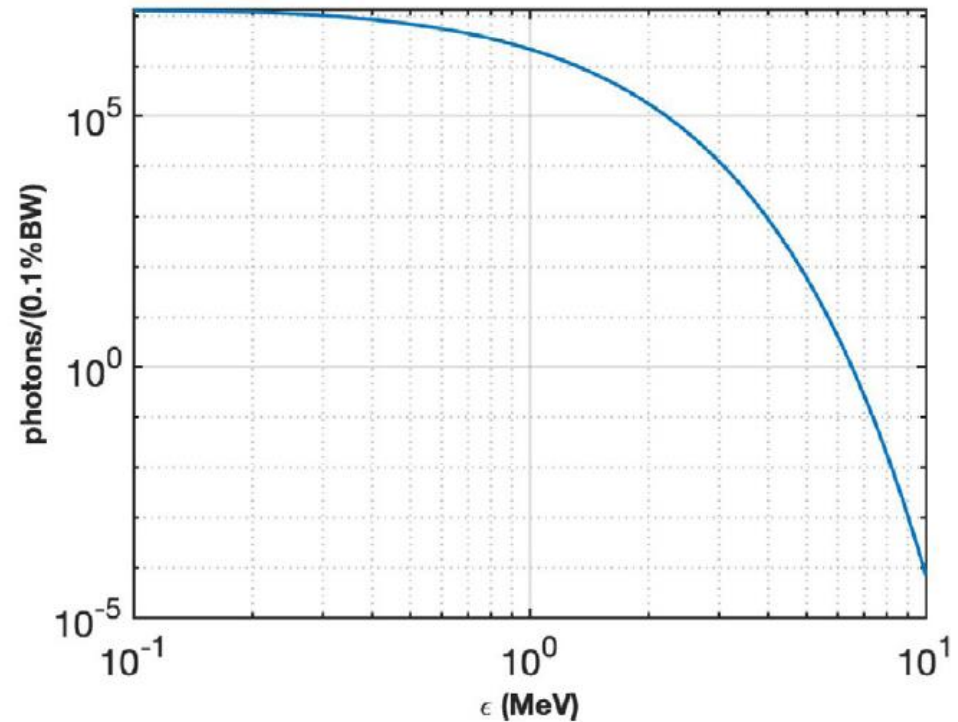
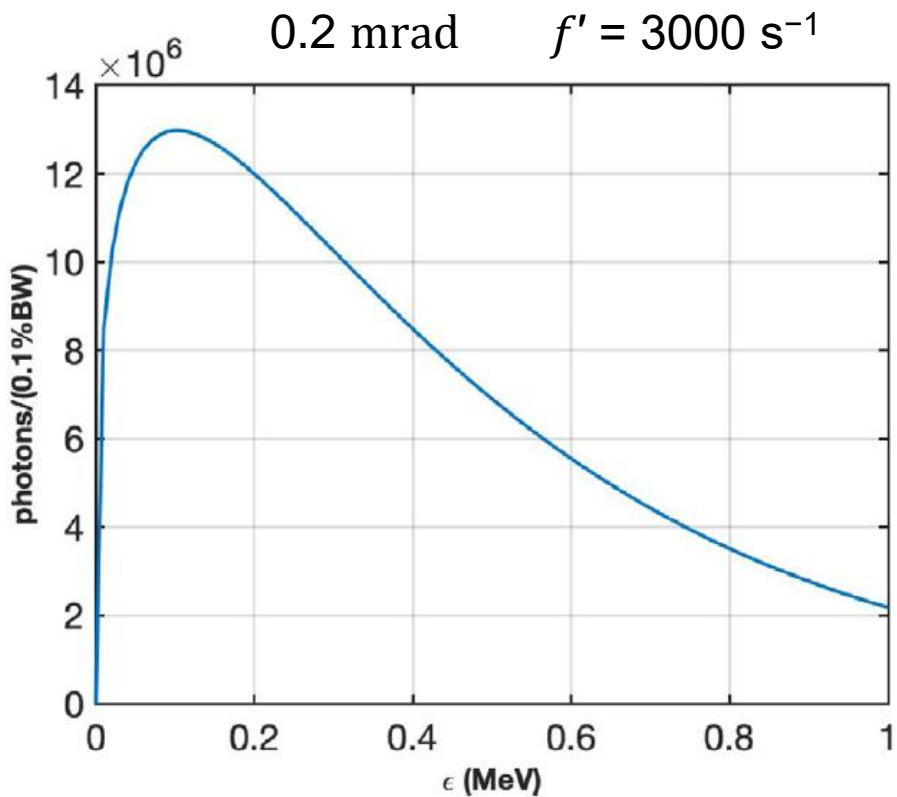
- For $\omega'_{max} = 9$ MeV, the luminosity of the three parts is $4.3 \times 10^{33} /m^2$, $5.14 \times 10^{33} /m^2$, $3.18 \times 10^{33} /m^2$.
- The number of the scattered photons in the three parts is 17193, 20541, 12725 respectively.



Synchrotron Radiation

The photon flux (photons/s/mrad /0.1%BW):

$$\frac{dF_{bm}(y)}{d\theta} = 2.457 \times 10^{13} E(\text{GeV}) I(A) G(y) \quad G(y) = y \int_y^\infty K_{\frac{5}{3}}(y') dy,$$



Monte-Carlo Simulation

- The energy spectrum of the scattered photons

- The scattered photons and the synchrotron radiation.

- Photons flux spectrum

400 cm polyethylene and 0.2 cm lead

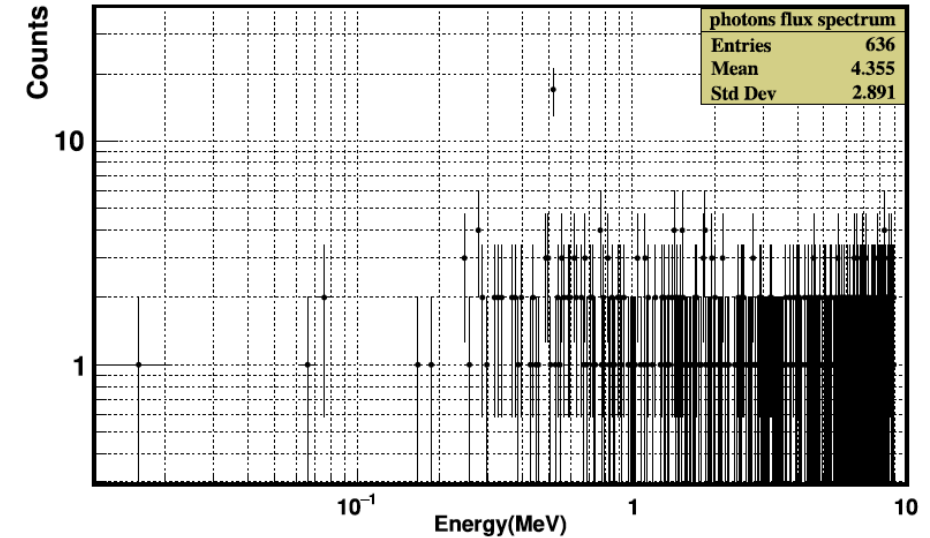
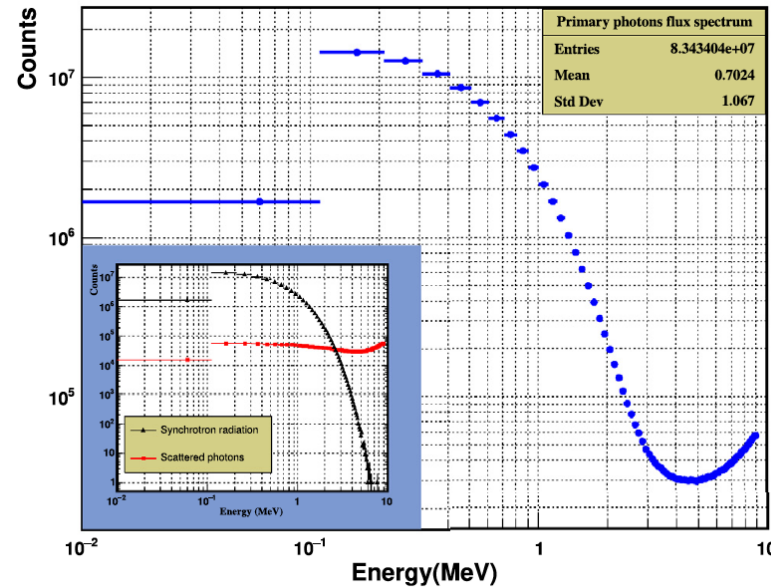
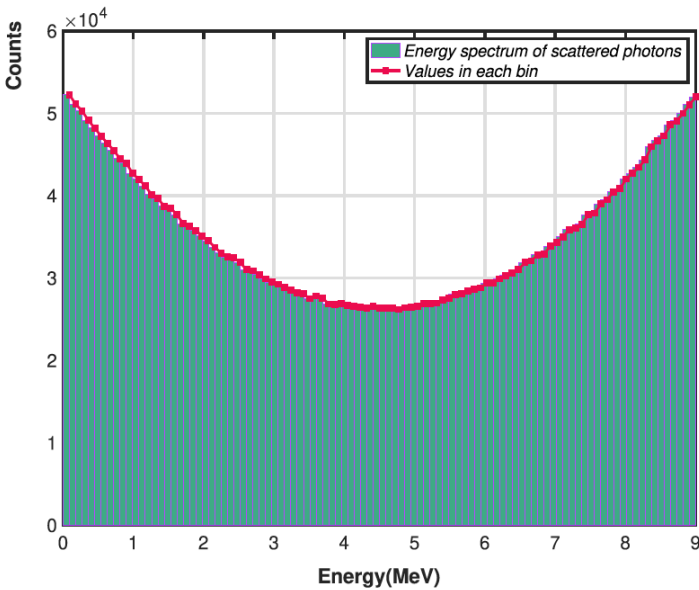


Table 2

The number of synchrotron radiation and scattered photons before and after shielding. B is the signal-to-noise ratio. After shielding, low-energy synchrotron radiation photons are absorbed.

Energy (0–9 MeV)	Before shielding	After shielding
Scattered photons(S)	3.519913×10^6	648
Synchrotron radiation(N)	7.991446×10^7	2
B(S/N)	0.44	324

Effect of the Hole Radius

The resonance frequency and Q value of the cavity comes from the theoretical calculation, the CST simulations without holes and the CST simulations with the hole radius, 0.15 mm.

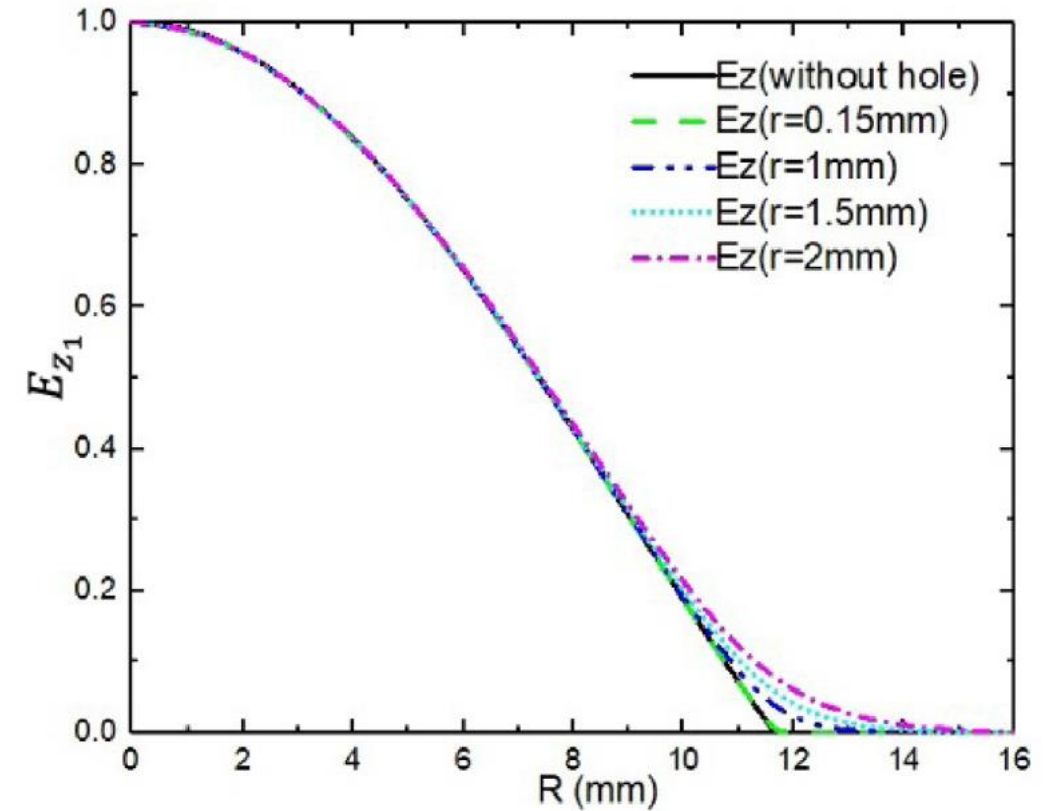
Parameter	Frequency (GHz)	Q value
Theoretical calculation	9.848975	11055.4
Simulation (without hole)	9.848976	11048.2
Simulation (hole radius 0.15 mm)	9.848973	11043.8

The variation of the resonance frequency in the cavity with the hole radius 1 mm, 1.5 mm, and 2 mm. The resonance frequency decreases slightly with the increase of the hole radius. The influence on the resonance frequency can be corrected by fine-tuning the cavity size.

Hole radius/mm	Frequency/GHz
1.0 mm	9.84790
1.5 mm	9.84533
2.0 mm	9.84026

- **Almost no effect on the field, the effect on the frequency can be compensated.**
- The energy storage in the cavity is 0.001J.

$$W = \frac{\epsilon_0}{2} \cdot 2\pi l E_m^2 \int_0^R J_0^2\left(\frac{2.405}{R}r\right) r dr = \frac{1}{2} \pi \epsilon_0 R^2 l E_m^2 J_1^2(2.4)$$



Possible Background

The effect of radiation in the field on the electron beam.

- In the TM_{010} mode:

$$E_{z_1} = E_m J_0(K_c r_1),$$

$$\bar{E}_{z_1} = \frac{\int_{-R}^R E_{z_1} dr_1}{2R}.$$

$$\bar{E}_{z_1} = 6.11351 \times 10^6 \text{ V/m}$$
- Electric Field:

$$E = \gamma m_0 c^2 = 120 \text{ GeV}$$

$$F = q \bar{E}_{z_1} = \frac{\gamma m_0 c^2}{r}$$

$$r = 19.629 \text{ km};$$

Bending radius

$$\epsilon_c = 2.218 \frac{E^3}{r} = 195.257 \text{ keV}$$

Critical energy
- Electric Field:

$$H_\varphi = -E_m \frac{1}{\eta} J_1(K_c r) \sin \omega t$$

$$r = 28.837 \text{ km};$$

Bending radius

$$\epsilon_c = 2.218 \frac{E^3}{r} = 132.828 \text{ keV}$$

Critical energy
- Synchrotron Radiation: Bending radius: **10.7 km**, Critical energy: **352.8 keV**.

Error analysis

- The laser alignment accuracy is up to 5×10^{-7} ;
- The stability of the high-frequency microwave source itself can reach $10^{-5} \sim 10^{-6}$;
- Assuming the detector can reach the order of 10^{-4} under good calibration;
- The measurement accuracy of the beam energy can reach the **6MeV@120GeV** ($\Delta E/E \sim 5 \times 10^{-5}$)

Summary

Laser-Compton

- **1D fitting: 1MeV@120GeV, 0.6@80GeV, 0.3@40GeV**
- **2D fitting: 0.4 MeV@120GeV**

Microwave-Compton

- **6MeV@120GeV; <6MeV@80GeV;**
- **A simple method+ γ SR beamline**

Center of Mass

- **Potential corrections of c.m. energy**
- **Beam energy uncertainties from surroundings**

Thanks



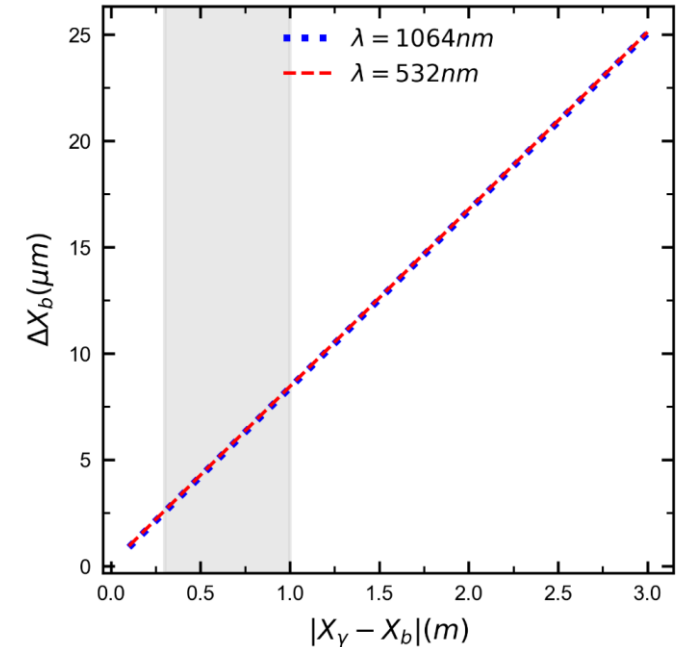
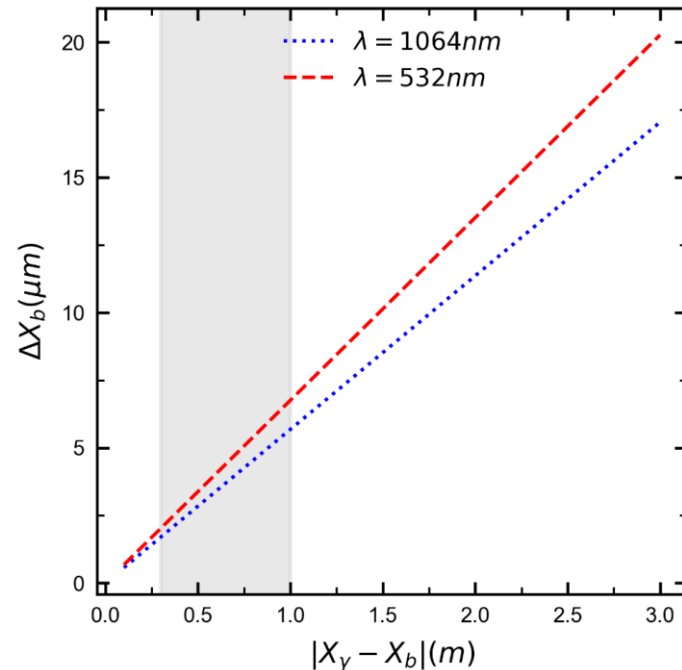
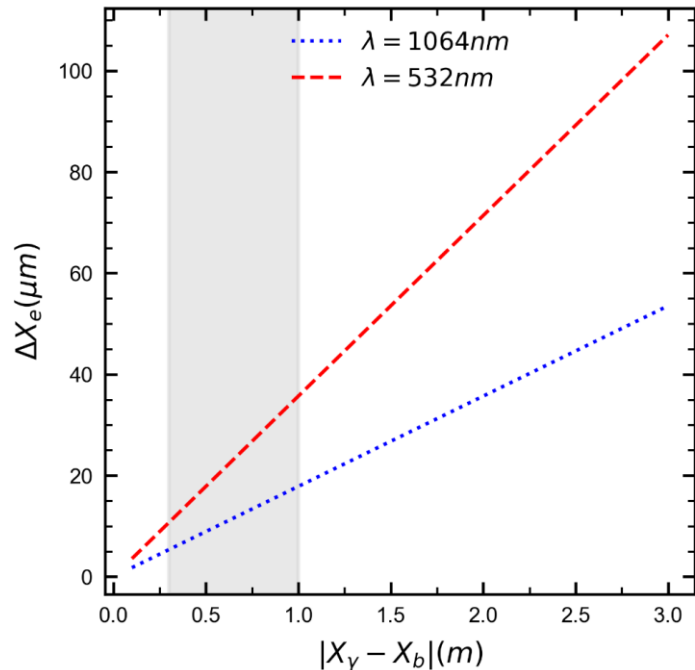
Backup



Requirement of measurement accuracy

$$1\text{MeV} \longleftarrow \frac{\Delta E_{beam}}{E_{beam}} = \sqrt{\left(\frac{\Delta X_{edge}}{|X_{edge} - X_{beam}|}\right)^2 + \left(\frac{|X_{\gamma} - X_{edge}| \Delta X_{beam}}{|X_{beam} - X_{\gamma}| |X_{edge} - X_{beam}|}\right)^2 + \left(\frac{\Delta X_{\gamma}}{|X_{beam} - X_{\gamma}|}\right)^2}$$

➤ The requirement for the measurement of positions: ΔX_{edge} , ΔX_{beam} , ΔX_{γ}



Systematic deviation

- Considering the track of scattered electrons of different energies in dipole
- The deviation by the synchrotron radiation.

Source	Error of device	Systematic deviation in beam energy
Dipole (0.5T, 3m)	$\Delta B/B = 0.2\%$	$\Delta E = 9.75 \pm 0.04 \text{ MeV}$
Position deviation by scattered electrons with different energies	$\frac{\Delta s}{s} = 4.8 \times 10^{-5}$	$\Delta E = 5.76 \text{ MeV}$

- More systematic error sources need to be considered.
- Extrapolating the center-of-mass energy needs to be considered.